

Substitute for form 1449A/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>	<i>Complete if Known</i>	
	Application Number	10/759,081 <b>RECEIVED</b>
	Filing Date	January 20, 2004 <b>CENTRAL FAX CENTER</b>
	First Named Inventor	Dr. Chou H. Li <b>NOV 01 2006</b>
	Group Art Unit	2815
	Examiner Name	William F. Kraig
Sheet 1 of 5	Attorney Docket Number	2480.202

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code <sup>2</sup> (if known)		
WFK	AA	3,283,171		Seeds	11-01-1966
WFK	AB	3,585,714		Li	06-22-1971
WFK	AC	3,752,711		Kooi, et al.	08-14-1973
WFK	AD	3,098,160		Noyce	07-16-1963
WFK	AE	3,233,305		Dill	02-08-1966
WFK	AF	3,386,865		Doo	06-04-1968
WFK	AG	3,360,696		Nelson, et al.	12-26-1967
WFK	AH	3,411,051		Kilby	11-12-1968
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WFK	AL	3,345,222		Nomura, et al.	10-03-1967
WFK	AM	3,440,717		Hill	04-28-1969
WFK	AN	3,492,174		Nakamura, et al.	01-27-1970
WFK	AO	3,520,139		Elkind, et al.	07-14-1970
WFK	AP	3,515,956		Martin, et al.	06-02-1970

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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<sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.

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WFK	AQ	3,581,161		Cunningham, et al.	05-25-1971
WFK	AR	3,586,542		MacRae	06-22-1971
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WFK	BH	2,911,706		Wertwijn	11-10-1959
WFK	BI	2,980,830		Shockley	04-18-1961
WFK	BJ	3,136,897		Kaufman	06-09-1964
WFK	BK	5,361,326		Aparicio, IV, et al.	11-01-1994

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Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T <sup>6</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind <sup>5</sup> Code (if known)			
WFK	BL	GB	1086607			10-1967	
WFK	BM	JP	S34-2529			04-16-1959	
WFK	BN	GB	1214203			12-02-1970	

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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>2</sup>
WFK	BO	"Integrated Circuits Design Principles and Fabrication," McGraw-Hill Book Co., Inc., 1965, pp. 127-31; 145-50; 174-85; Fig. 5-4(a), p. 131; Fig. 5-23, p. 146; Fig. 5-25 -5-27, pp. 147-48; Fig. 7-1, p. 175; Fig. 7-2, p. 176; Fig. 7-6(a), p. 179. no month cited	
WFK	BP	"New Isolation Method Shrinks Bipolar Ics," Electronics, McGraw-Hill, Mar. 1, 1971, pp. 52-55, Fig. 5-6, p. 55.	
WFK	BQ	"Diffusion Depths in Silicon Measured Using Cylindrical Grooves," The American Physical Society Abstracts from the Epitome of the 1956 Monterey Meeting, Session H, Nov. 1956.	
WFK	BR	McDonald, et al., "Measurement of the Depth of Diffused Layers In Silicon By the Grooving Method," Journal of the Electrochemical Society, Vol. 109, No. 2, Feb. 1962. pp. 141-144 - see Fig. 2 and p. 143.	
WFK	BS	Jones, R.E. and Doo, Y., "A Composite Insulator-Junction Isolation," Electrochemical Technology, May-June 1967.	
WFK	BT	Breener, S.S., "The Growth of Whiskers by the Reduction of Metal Salts," Acta Metallurgica, Vol. 4, Jan. 1956, pp. 62-74.	
WFK	BU	Stiles, P.J., et al., "Schottky Barrier Diode", IBM Technical Disclosure Bulletin, Vol. 11 No. 1, June 1968, p. 20.	
WFK	BV	Doo, Y., et al., "Making Monolithic Semiconductor Structures for Integrated Circuits Using Composite Insulation and Junction Isolation Techniques," IBMS Technical Disclosure Bulletin, Vol. 8 No. 4, Sept. 1965, pp. 659-660.	
WFK	BW	Phillips, A.B., "Transistor Engineering," McGraw-Hill, 1962, pp. 111-115. no month cited	
WFK	BX	Burrill, J.T., et al., "Ion Implantation as a Production Technique," IEEE Transactions on Electron Devices, Vol. Ed-14, No. 1, Jan. 1967, pp. 10-17.	
WFK	BY	Buchanan, B., et al., "High Energy (1 to 2.5 Mev) Ion Implantation For Obtaining Novel Semiconductor Junction Structures," Air Force Cambridge Res. Labs., Off. Of Aerospace Research, Bedford, MA, pp. 649-684. no date cited	
WFK	BZ	Gibbons, J.F., "Ion Implantation in Semiconductors-Part I Range Distribution Theory and Experiments," Proceedings of the IEEE, Vol. 56, No.3, March 1968, pp. 295-318.	

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WFK	CA	NOTES, Solid-State Electronics, Pergamon Press, 1967, Vol. 10, pp. 1105-1108, Printed in Great Britain. no month cited	
WFK	CB	Kennedy, D.P., et al., "Calculations of Impurity Atom Diffusion Through a Narrow Diffusion Mask Opening," IBM Journal, Jan. 1966, pp. 6-12.	
WFK	CC	Appels, J.A., et al., "Local Oxidation of Silicon and Its Application in Semiconductor-Device Technology, Philips Res. Repts. 25, 1970, pp. 118-132. no month cited	
WFK	CD	Doo, V.Y., "Silicon Nitride, A New Diffusion Mask, IEEE Transactions on Electron Devices, Vol. Ed.-13, No. 7, July 1966, pp. 561-563.	
WFK	CE	S.S. Brenner, "The Growth of Whiskers by the Reduction of Metal Salts", Acta Metallurgica, Vol. 4 (January 1956) pp. 62-74.	

<i>William F. Kraig</i> /William Kraig/	12/08/2006
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